

UNIVERSITY OF CALIFORNIA, BERKELEY
College of Engineering
Department of Electrical Engineering and Computer Sciences

EE 130/230M
Integrated Circuit Devices

Spring 2013
Prof. Liu & Dr. Xu

QUIZ #3
Time allotted: 25 minutes

NAME: SOLUTIONS

(print) Last _____ First _____ Signature _____

STUDENT ID#: _____

1. Use the values of physical constants provided below.
2. SHOW YOUR WORK, and write legibly!
3. Underline or box numerical answers, and specify units where appropriate.

Physical Constants

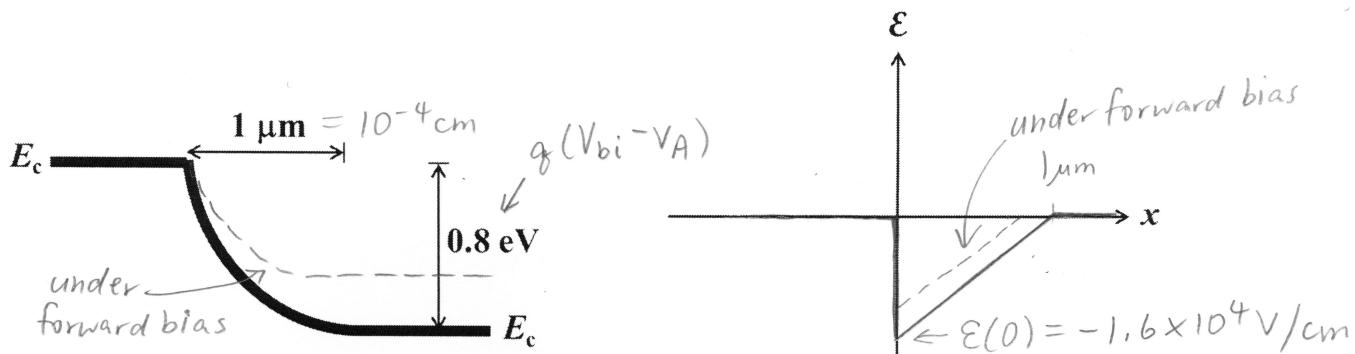
Description	Symbol	Value
Electronic charge	q	$1.6 \times 10^{-19} \text{ C}$
Thermal voltage at 300K	kT/q	0.026 V

Properties of silicon (Si) at 300K

Description	Symbol	Value
Energy band gap	E_G	1.12 eV
Intrinsic carrier concentration	n_i	10^{10} cm^{-3}
Permittivity	ϵ_{Si}	$1.0 \times 10^{-12} \text{ F/cm}$

Problem 1 [13 points]

The conduction band edge (E_c) profile for a Si pn step junction in equilibrium at $T = 300\text{K}$ is shown below.



- a) Which side is more heavily doped? Justify your answer. [2 pts] p-side

All of the energy band bending occurs on the n-side (i.e. $x_n \gg x_p$). Therefore, all of the voltage is dropped on the n-side, so it is more lightly doped.

- b) What is the dopant concentration on the more lightly doped side of the pn junction? [4 pts]

$$W = \sqrt{\frac{2\epsilon_s(V_{bi} - V_A)}{qN_D}}$$

$$\Rightarrow N_D = \frac{2\epsilon_s(V_{bi} - V_A)}{qW^2} = \frac{2(10^{-12})(0.8)}{(1.6 \times 10^{-19})(10^{-4})^2} = \underline{\underline{10^{15} \text{ cm}^{-3}}}$$

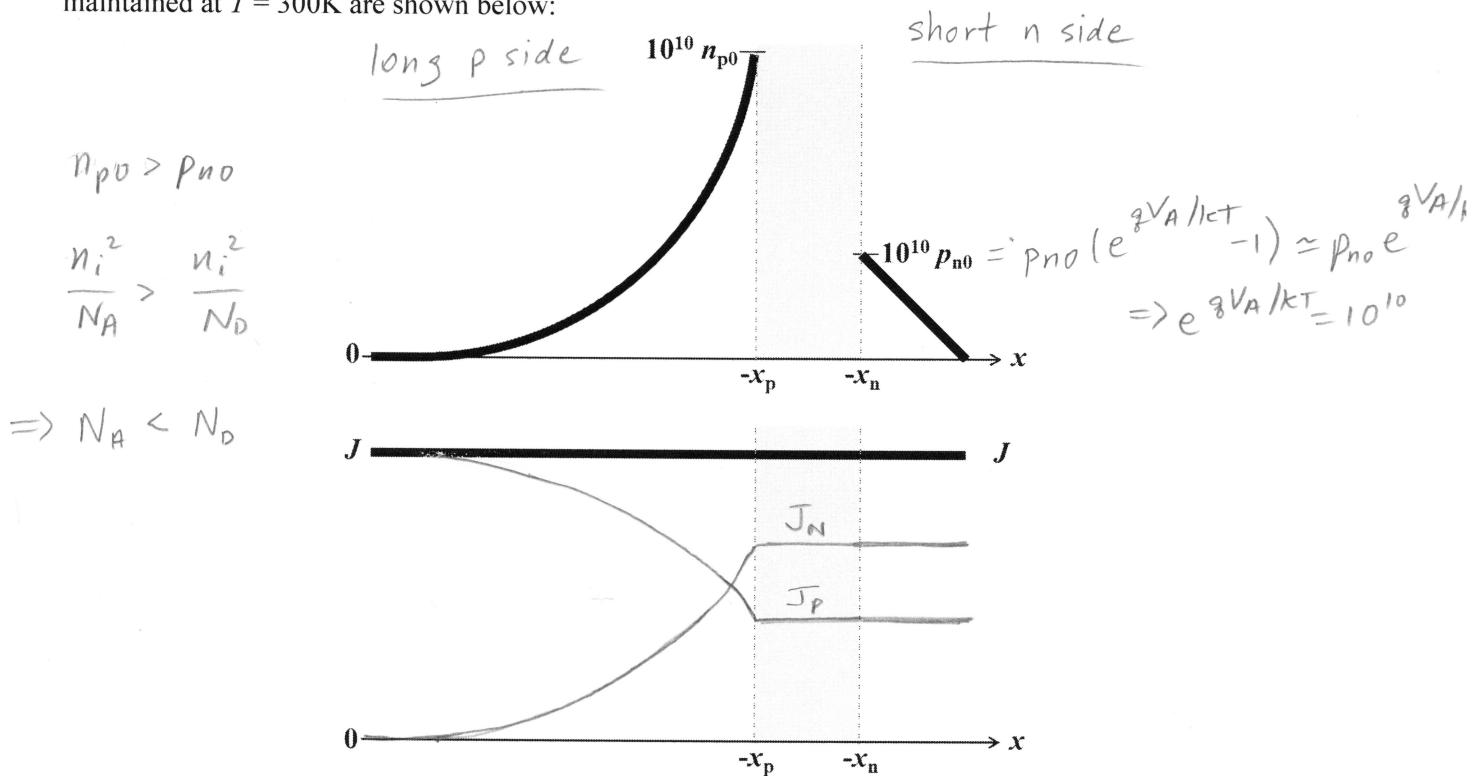
- c) Sketch the electric field (\mathcal{E} -field) distribution on the axes provided above. Indicate the peak value. [4 pts]

$$\frac{1}{2} |\mathcal{E}(0)| W = 0.8 \text{ V} \Rightarrow |\mathcal{E}(0)| = \frac{2 \times 0.8}{10^{-4}} = \underline{\underline{1.6 \times 10^4 \text{ V/cm}}}$$

- d) Qualitatively show how the band edge profile and \mathcal{E} -field distribution change under forward bias. [3 pts]

Problem 2 [7 points]

The excess minority carrier concentrations within the quasi-neutral regions of a Si pn step junction maintained at $T = 300\text{K}$ are shown below:



a) What is the magnitude of the applied bias voltage, V_A ? [3 pts]

$$(kT/q) \cdot \ln(10) = 0.06 \text{ V}$$

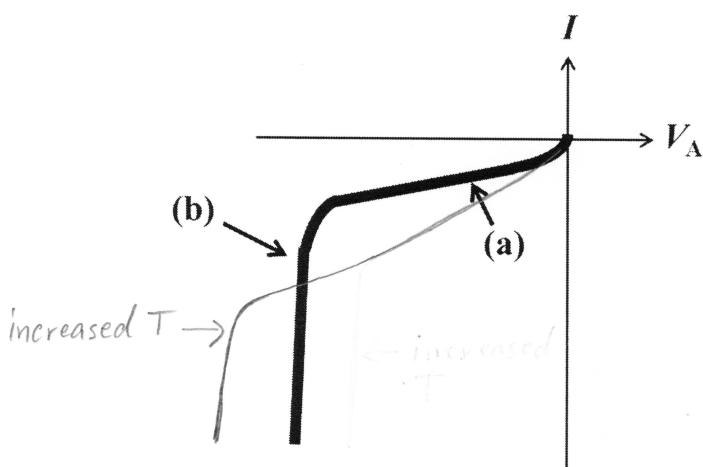
$$e^{qV_A/kT} = 10^{10} \Rightarrow V_A = \frac{kT}{q} \ln(10^{10}) = 10 \cdot \frac{kT}{q} \ln(10) = \underline{\underline{0.6 \text{ V}}}$$

b) Sketch the hole and electron current density components (J_P and J_N) on the plot provided above. [4 pts]

The n side is more heavily doped, so J_N will be larger than J_P within the depletion region.

Problem 3 [5 points]

The reverse-bias $I-V$ characteristic of a non-degenerately doped pn junction diode maintained at $T = 300\text{K}$ is shown below. Indicate the causes of the indicated non-ideal behaviors below:



(a) Net generation in and [2 pts]
within one minority-carrier
diffusion length of depletion region.

(b) Avalanche breakdown [1 pts]

(c) Show how the characteristic would change if the temperature were to be increased. [2 pts]